

APPLICATION DATA SHEET

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Title of Invention: COMPOSITION AND CHEMICAL VAPOR DEPOSITION METHOD FOR FORMING ORGANIC LOW K DIELECTRIC FILMS

Customer Number Correspondence Address: 25559



INVENTOR(s):

Primary Citizenship: US
Given Name: Neil
Middle Name: H
Family Name: Hendricks
Residence City: Sonora
Residence State: CA
Residence Country: US
Address: 16525 Habitat Tr.
Senora CA, 95370 US